

## Editorial

Jack D. Gaskill, Editor

# SPIE—An International Society

When the Society of Photo-Optical Instrumentation Engineers (SPIE) began calling itself SPIE—The International Society for Optical Engineering in 1981, an important motivating factor was the desire of the Society's Governors to reflect a rise in the membership from countries other than the United States and to foster an increase in cooperative activities with the optical engineering communities within those countries. At a time when the Society's technical focus had drifted away from photographic instrumentation and toward optical engineering, its membership had become less exclusively comprised of individuals from the U.S. and was beginning to develop a much more international flavor.

Although the majority of members by far are still from the U.S., nearly one out of every five is not. As of 21 April 1987, the membership breakdown of the Society by country was as follows:

Argentina	Japan Korea Kuwait Liechtenst Mexico Netherlan New Zeala Nigeria Philippine Poland Portugal . Saudi Ara Singapore South Afr Spain Sweden . Switzerlar Thailand . U.S United Ki U.S.S.R Federal Re of Gerr Yugoslavia Zimbabwa

Japan
Liechtenstein3
Mexico
Netherlands 49
New Zealand
Nigeria1
Norway
Philippines1
Poland 17
Portugal7
Saudi Arabia1
Singapore6
South Africa
Spain
Sweden
Switzerland 49
Thailand1
U.S 6663
United Kingdom 224
U.S.S.R1
Federal Republic
of Germany 126
Yugoslavia5
Zimbabwe1

Total ..... 8061

The goal to increase the international activities of the Society has been met quite successfully, with major technical symposia having been held in Geneva in 1983, Cannes in 1985, Innsbruck and Quebec in 1986, and in The Hague this spring. In addition, symposia are scheduled in Cannes again this coming fall and in Hamburg next year. I am looking forward to even more international cooperation in the years to come and would like to encourage those from abroad to join the Society and take an active part in its future.

# **OPTICAL ENGINEERING** EDITORIAL SCHEDULE

## August 1987

## CCD Characterization, Modeling, and Application

James R. Janesick Jet Propulsion Laboratory California Institute of Technology 4800 Oak Grove Drive Pasadena, CA 91109 818/354-7734

## September 1987

**CCD** Manufacture and Application lames R. Janesick

## October 1987

**CCD and CID Theory and Application** James R. Janesick

## November 1987

#### **Optomechanical Instrument Design**

**Roger Reiss** Lockheed Missiles & Space Co., Inc. Space Systems Div. O/6206 B/151 1111 Lockheed Way Sunnyvale, CA 94089-3504 415/965-3888

Daniel Vukobratovich **Optical Sciences Center** University of Arizona Tucson, AZ 85721 602/621-4219

#### December 1987

#### Contributed papers on optical engineering

#### January 1988

# Progress of Optics in the United Kingdom

John C. Dainty Blackett Laboratory Imperial College London SW7 2B2, UK Kent BR7 5EH, UK 01-589-5111

Lionel R. Baker Sira Ltd. South Hill, Chislehurst 01-467-2636

#### February 1988

#### **Neural Networks**

William J. Miceli Office of Naval Research 495 Summer Street Boston, MA 02210-2105 617/451-4484

## March 1988

#### **Photomechanics I**

Fu-Pen Chiang SUNY/Stony Brook Lab. for Experimental Mechanics Research Stony Brook, NY 11794 516/246-6768

April 1988

**Photomechanics II** Fu-Pen Chiang